



ELECTRONIC COPY

LG572369627

Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT

March 13, 2023
IGI Report Number **LG572369627**
Description **LABORATORY GROWN
DIAMOND**
Shape and Cutting Style **MODIFIED SHIELD STEP CUT**
Measurements **12.86 X 7.10 X 3.82 MM**

GRADING RESULTS

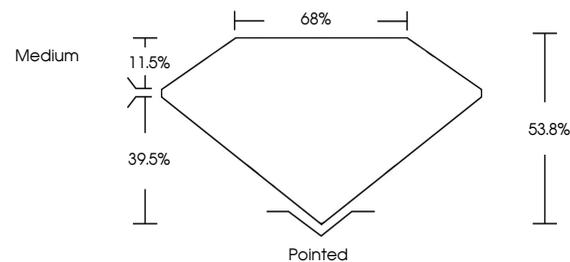
Carat Weight **2.01 CARATS**
Color Grade **D**
Clarity Grade **SI 1**

ADDITIONAL GRADING INFORMATION

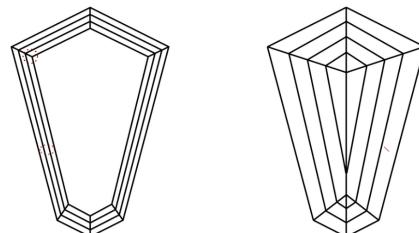
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG572369627**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment. Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

GRADING SCALES

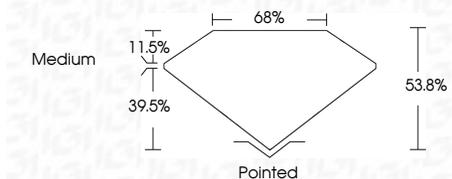
CLARITY

IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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Sample Image Used



IGI

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MODIFIED SHIELD STEP CUT
12.86 X 7.10 X 3.82 MM
2.01 CARATS
Carat Weight **D**
Color Grade **SI 1**
Depth **68.0%**
Table **65%**
Girdle **Medium**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG572369627**

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